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Bib Data Sheet

CONFIRMATION NO. 7243

<b>SERIAL NUMBER</b> 09/724,002	<b>FILING DATE</b> 11/28/2000 <b>RULE</b>	<b>CLASS</b> 118	<b>GROUP ART UNIT</b> 1734	<b>ATTORNEY DOCKET NO.</b> SEL 231
<b>APPLICANTS</b> Shunpei Yamazaki, Tokyo, JAPAN; Toshimitsu Konuma, Kanagawa, JAPAN; Takeshi Fukunaga, Kanagawa, JAPAN;				
<b>** CONTINUING DATA *****</b> NONE ku 9/29/04				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 11-337190 11/29/1999 ✓ ku 9/29/04				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> ** 03/24/2001				
<b>Foreign Priority claimed</b> <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 8	<b>TOTAL CLAIMS</b> 30
<b>Examiner's Signature</b> <i>[Signature]</i>		<b>Initials</b> <i>[Initials]</i>	<b>INDEPENDENT CLAIMS</b> 10	
<b>ADDRESS</b> COOK, ALEX, McFARRON, MANZO CUMMINGS & MEHLER, LTD. Suite 2850 200 West Adams St. Chicago, IL 60606				
<b>TITLE</b> Film deposition apparatus and a method of manufacturing a light emitting device using the apparatus				
<b>FILING FEE RECEIVED</b> 1580	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	